Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	4102	(substrate or wafer) near5 groove$1 and etch	USPAT; EPO; JPO; DERWENT	OR	OFF	2005/03/31 17:50
L2	46	1 and blind	USPAT; EPO; JPO; DERWENT	OR	OFF	2005/03/31 17:50